



in 205-28-1

PATENT APPLICATION

AF
LW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
SUNGHO JIN ET AL.)
Application No.: 10/054499)
~~10/141,421~~)
Filed: 01/22/2002)
For: Optical Systems Comprising Curved)
MEMs Mirrors and Methods for Making)
Same)
January 13, 2005

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Final Office Action mailed December 2, 2004, please amend
the above-identified application as follows:

I hereby certify that this correspondence is being deposited
with the United States Postal Service as first-class mail in an
envelope addressed to: Commissioner for Patents, P.O. Box
1450, Alexandria, VA 22313-1450 on

January 13, 2005

Date of Deposit

Glen E. Books

Glen E. Books
Signature

January 13, 2005
Date of Signature